

***Supplementary Information***

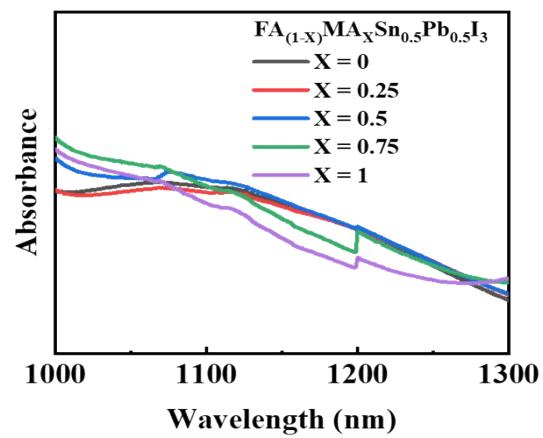
**Regulating Energy Band Alignment for High-performance Broadband  
Perovskite Photodetectors**

Jun Wu<sup>1</sup>, Yuchen Miao<sup>1</sup>, Xiaorong Qi<sup>1</sup>, Liu Yang<sup>1</sup>, Xu Wang<sup>1</sup>, Fei Zheng<sup>1</sup>, Feiyu Zhao<sup>1</sup>, Zhenfu Zhao<sup>1</sup>, Shareen Shafique<sup>1</sup>, Houcheng Zhang<sup>2</sup>, Ziyang Hu<sup>1,\*</sup>

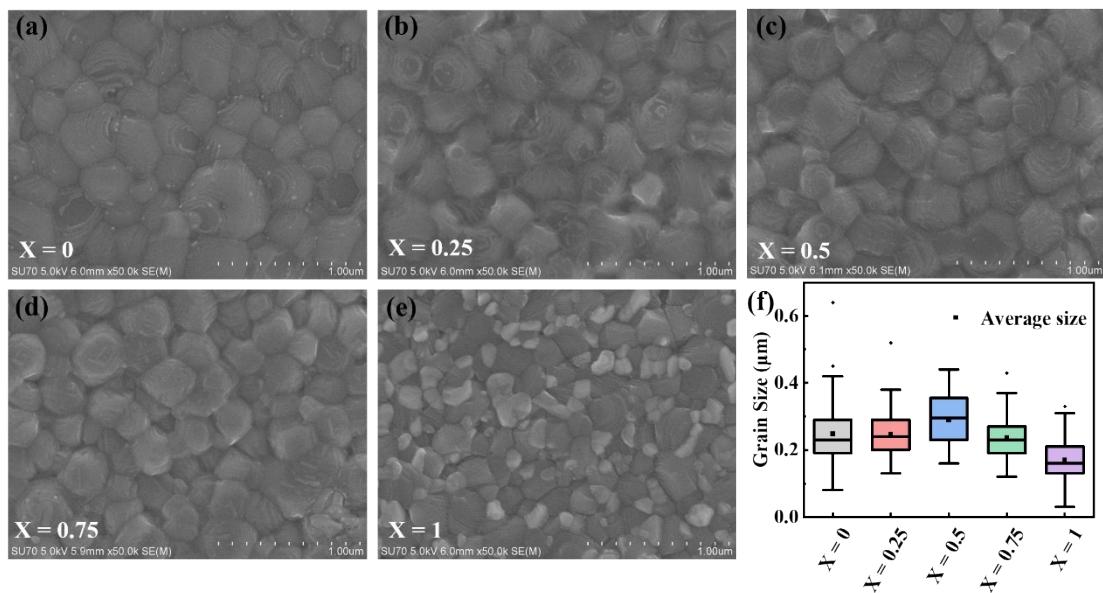
<sup>1</sup>Department of Microelectronic Science and Engineering, School of Physical Science and Technology, Ningbo University, Ningbo 315211, China

<sup>2</sup>College of New Energy, Ningbo University of Technology, Ningbo 315211, China

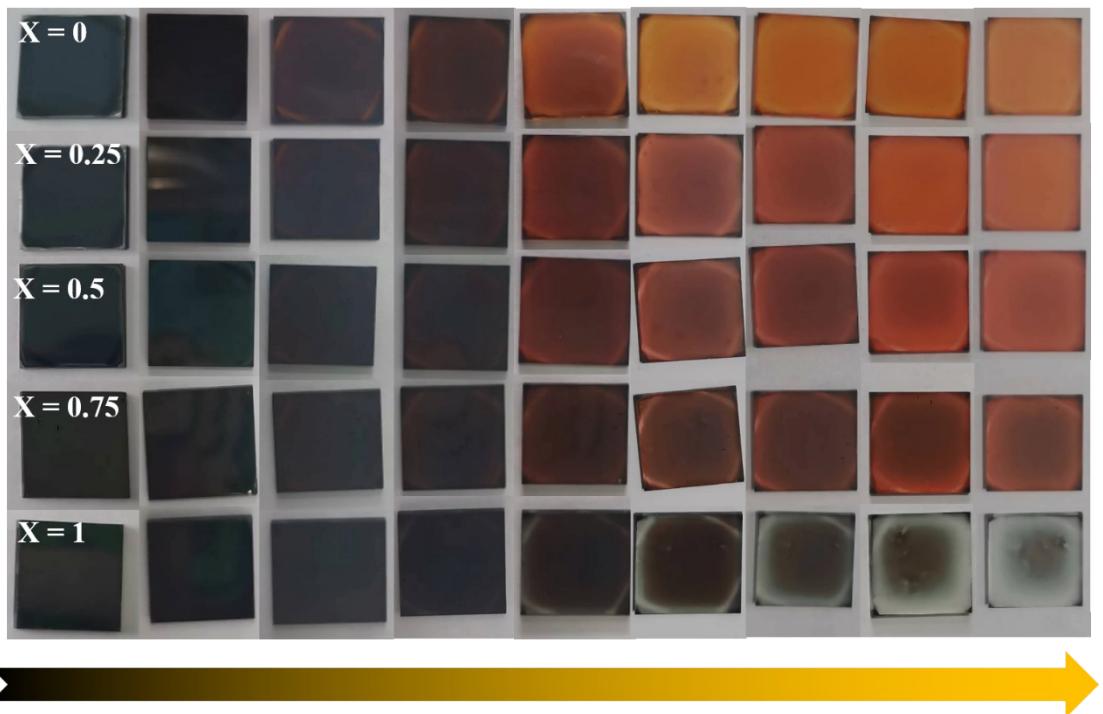
E-mail: [huziyang@nbu.edu.cn](mailto:huziyang@nbu.edu.cn).



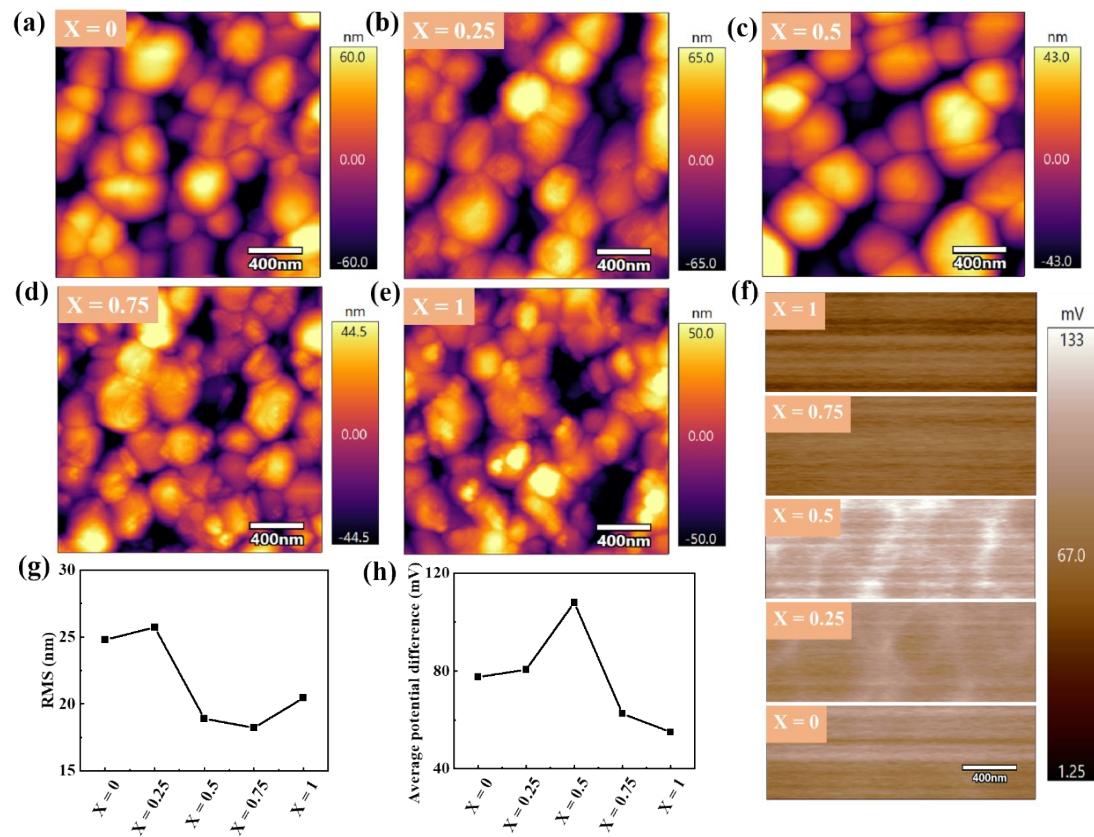
**Figure S1.** UV-vis-NIR absorption spectrum in the range of 1000-1300 nm



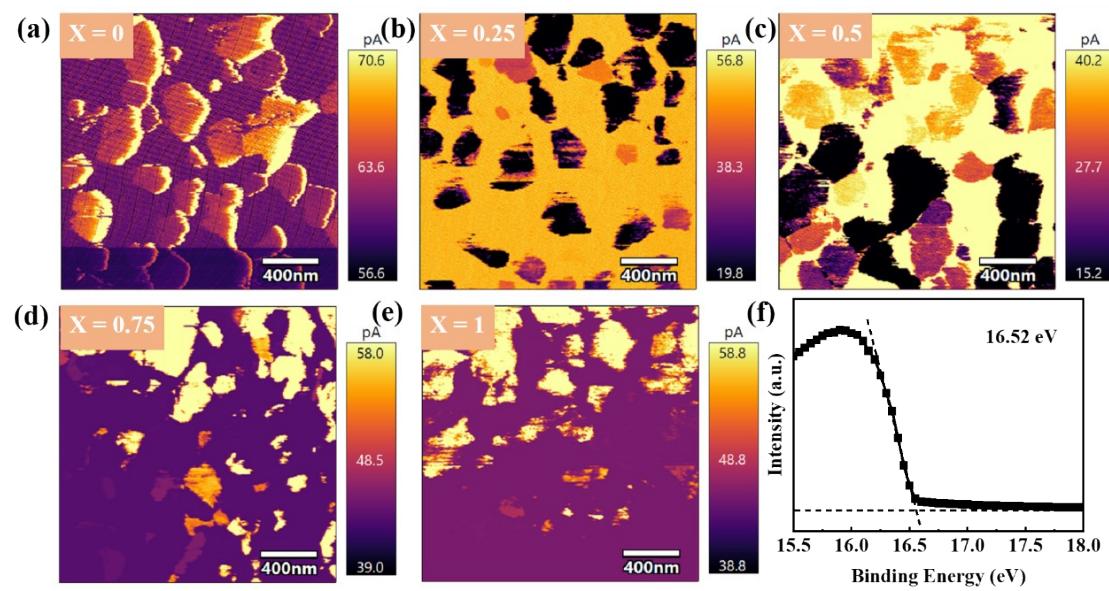
**Figure S2.** (a-e) SEM images of  $\text{FA}_{(1-x)}\text{MA}_x\text{Sn}_{0.5}\text{Pb}_{0.5}\text{I}_3$  perovskite films. (f) Statistical diagram of grain size of perovskite with different FA/MA compositions.



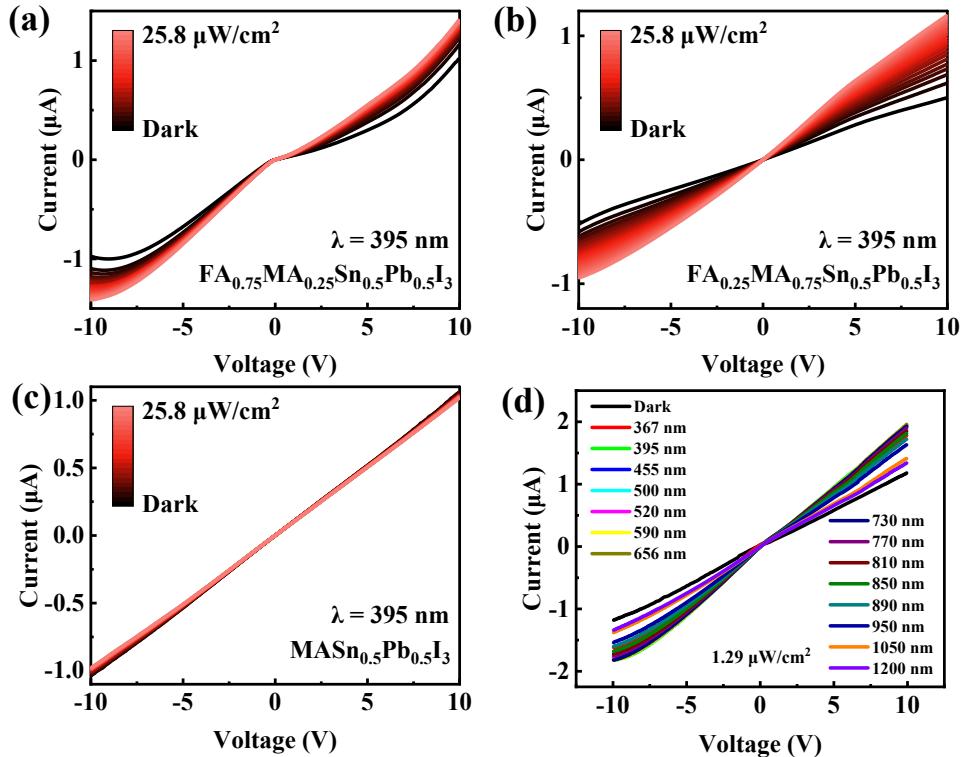
**Figure S3.** Degradation process of perovskite with different FA/MA components in room temperature air (25 °C, 60% RH).



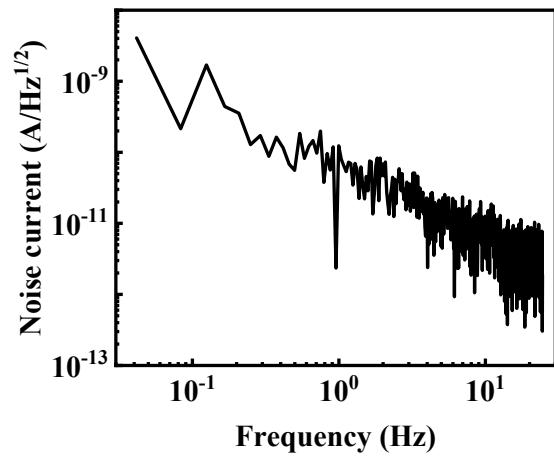
**Figure S4.** (a-e) AFM surface topography of  $\text{FA}_{(1-x)}\text{MA}_x\text{Sn}_{0.5}\text{Pb}_{0.5}\text{I}_3$  perovskite thin films. (f) KPFM diagrams, (g) Roughness comparison diagram and (h) Average potential difference comparison diagram of perovskite with various FA/MA compositions.



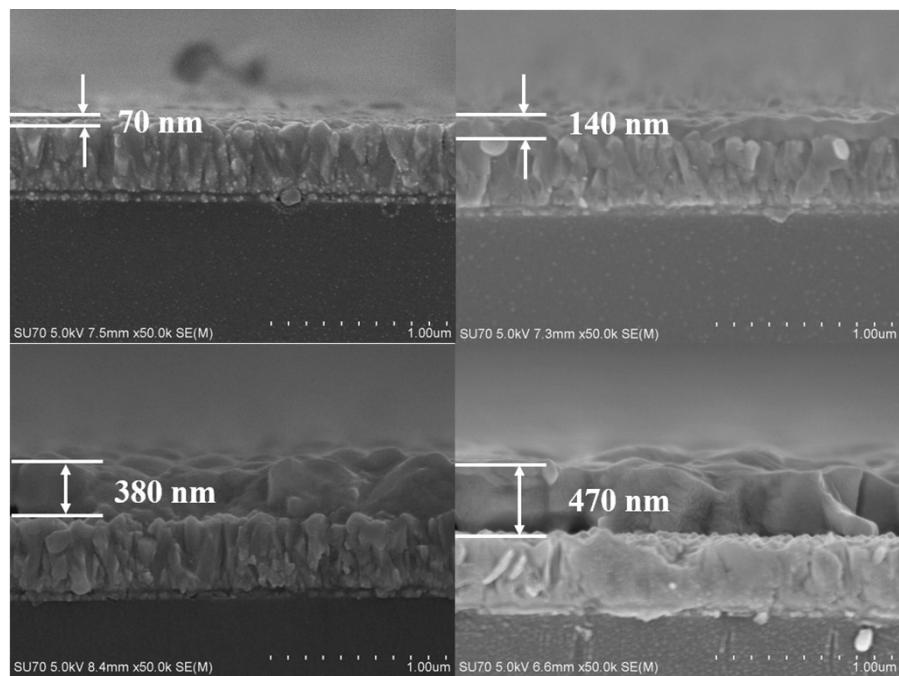
**Figure S5.** (a-e) C-AFM images of perovskite films with different FA/MA components. (f) UPS spectrum of ITO.



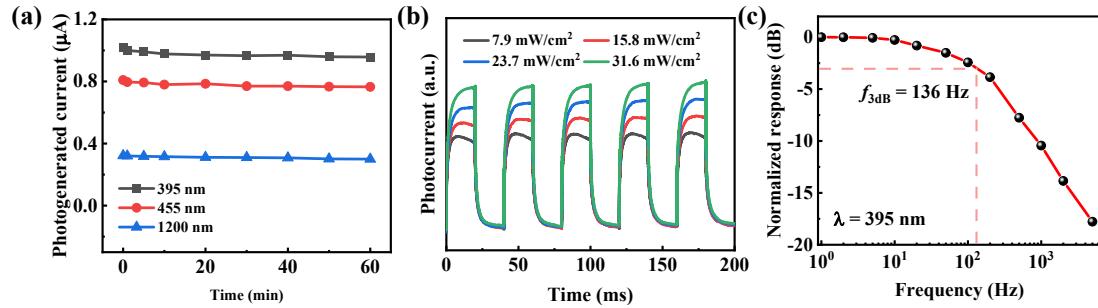
**Figure S6.** (a)  $I$ - $V$  curves under dark and illumination for  $\text{FA}_{0.75}\text{MA}_{0.25}\text{Sn}_{0.5}\text{Pb}_{0.5}\text{I}_3$  device, (b)  $\text{FA}_{0.25}\text{MA}_{0.75}\text{Sn}_{0.5}\text{Pb}_{0.5}\text{I}_3$  device and (c)  $\text{MASn}_{0.5}\text{Pb}_{0.5}\text{I}_3$  devices. (d)  $I$ - $V$  curves of the optimized device at 367-1200 nm ( $1.29 \mu\text{W}/\text{cm}^2$ ).



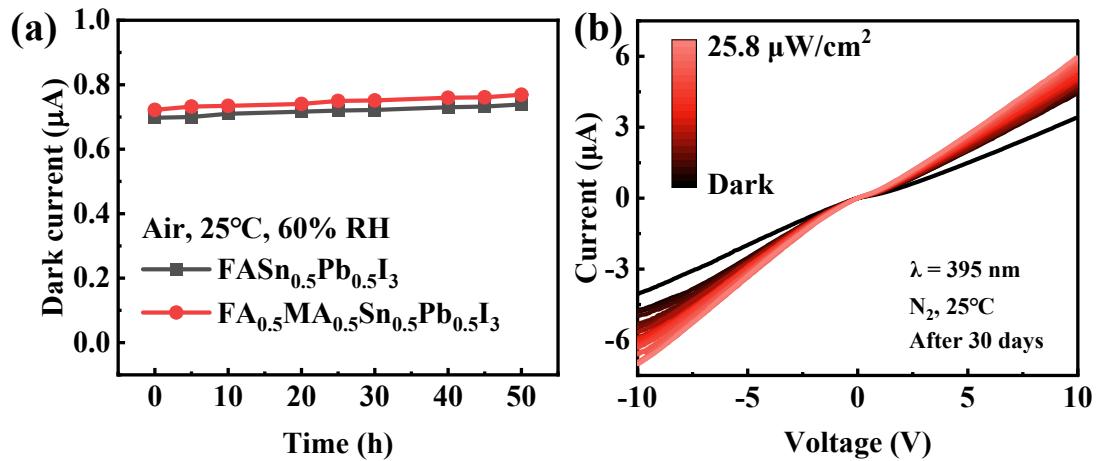
**Figure S7.** Noise spectral density curve.



**Figure S8.** SEM images of the cross section of perovskites.



**Figure S9.** (a) Changes of photogenerated current under long-term irradiation with different wavelengths. (b)  $I$ - $T$  curves of the photodetector under the illumination of 395 nm light. (c) Relationship between normalized light response change and frequency.



**Figure S10.** (a) Variation of dark current of devices with time. (b) After 30 days, the optical response curves at 395 nm.

**Table S1.** Comparison of perovskite photodetectors with wide spectrum response.

| Perovskite<br>(Wavelength range)   | Responsivity<br>(A/W)   | Detectivity<br>(Jones)   | Linear<br>dynamic<br>range<br>(dB) | Response<br>time ( $t_r/t_f$ ) | Ref.          |
|--|---|--|------------------------------------|--------------------------------|---------------|
| CsSnI <sub>3</sub> nanowire<br>(475-940 nm)  | 0.054<br>(940 nm)   | $3.85 \times 10^5$ (a)<br>(940 nm)   | —                                  | 83.8/243.4 ms                  | <sup>1</sup>  |
| (MAPbI <sub>3</sub> ) <sub>0.2</sub> (FASnI <sub>3</sub> ) <sub>0.8</sub><br>single crystals (405-1064<br>nm)                            | 0.247<br>(405 nm)<br>0.012<br>(1064 nm)   | $1.12 \times 10^{12}$ (a)<br>(405 nm)<br>$2.58 \times 10^{10}$ (a)<br>(1064 nm)                                      | —                                  | 59/41 ms                       | <sup>2</sup>  |
| FASnI <sub>3</sub> (500-850 nm)  | $1.1 \times 10^5$<br>(685 nm)   | $1.9 \times 10^{12}$ (b)<br>(685 nm)   | —                                  | 8.7/57 s                       | <sup>3</sup>  |
| MAPbBr <sub>3</sub> single crystals<br>(520-1450 nm)   | 5.04<br>(520 nm)  | $5.37 \times 10^{12}$ (b)<br>(520 nm)  | 122                                | 80 /110 $\mu$ s                | <sup>4</sup>  |
| (BA) <sub>2</sub> (MA)Sn <sub>2</sub> I <sub>7</sub> single<br>crystals (365-1064 nm)  | 28.4<br>(365 nm)<br>0.02<br>(1064 nm)   | $2.3 \times 10^{10}$ (a)<br>(365 nm)<br>$1.8 \times 10^7$ (a)<br>(1064 nm)   | —                                  | 0.6 /1.2 s                     | <sup>5</sup>  |
| (FASnI <sub>3</sub> ) <sub>0.1</sub> (MAPbI <sub>3</sub> ) <sub>0.9</sub><br>single crystals (350-840<br>nm)                             | 0.53<br>(800 nm)  | $7.09 \times 10^{10}$ (b)<br>(800 nm)  | 163.5                              | 22.78/20.35<br>$\mu$ s         | <sup>6</sup>  |
| Cs <sub>0.05</sub> MA <sub>0.45</sub> FA <sub>0.5</sub> Pb <sub>0.5</sub> Sn <sub>0</sub> . <sub>5</sub> I <sub>3</sub><br>(300-1050 nm) | 0.53<br>(910 nm)  | $2.07 \times 10^{11}$ (b)<br>(910 nm)  | —                                  | – /35.37 ns                    | <sup>7</sup>  |
| Cs <sub>0.05</sub> MA <sub>0.45</sub> FA <sub>0.5</sub> Pb <sub>0.5</sub> Sn <sub>0</sub> . <sub>5</sub> I <sub>3</sub><br>(300-1000 nm) | 0.29<br>(720 nm)<br>0.2<br>(940 nm)   | $3.4 \times 10^{12}$ (a)<br>$1.6 \times 10^9$ (b)  | 83.6                               | 2/2.1 $\mu$ s                  | <sup>8</sup>  |
| (MA <sub>0.5</sub> FA <sub>0.5</sub> )<br>(Pb <sub>0.5</sub> Sn <sub>0.5</sub> )I <sub>3</sub><br>(370-980 nm)                           | $1.7 \times 10^5$<br>(980 nm)<br>$5.8 \times 10^5$<br>(760 nm)<br>$4.6 \times 10^4$<br>(370 nm) | $5.9 \times 10^{13}$ (b)<br>(980 nm)<br>$2.0 \times 10^{14}$ (b)<br>(760 nm)<br>$1.6 \times 10^{13}$ (b)<br>(370 nm) | —                                  | 80/ – ms                       | <sup>9</sup>  |
| FA <sub>0.85</sub> Cs <sub>0.15</sub> Sn <sub>0.5</sub> Pb <sub>0.5</sub> I <sub>3</sub>   | 0.52<br>(910 nm)  | $8.48 \times 10^{12}$ (b)<br>(910 nm)  | 213                                | 67.5/720 ns                    | <sup>10</sup> |

| (300-1100 nm)   |   |  |     |                         |  |               |
|---|---|--|-----|-------------------------|--|---------------|
| $\text{Cs}_{0.15}\text{FA}_{0.85}\text{Pb}_{0.5}\text{Sn}_{0.5}\text{I}_3$<br>(325-980 nm)  | 0.52<br>(850 nm)  | $5.34 \times 10^{12}$ <sup>(b)</sup><br>(850 nm)   | 224 | - / 39.68 ns            |  | <sup>11</sup> |
| $\text{FA}_{0.8}\text{PEA}_{0.2}\text{SnI}_3$<br>(350-900 nm)                               | 0.262<br>(780 nm)   | $2.3 \times 10^{11}$ <sup>(b)</sup><br>(850 nm)  | 83  | 27.7/20.4 $\mu\text{s}$ |  | <sup>12</sup> |
| $\text{MA}_{0.3}\text{FA}_{0.7}\text{Pb}_{0.5}\text{Sn}_{0.5}\text{I}_3$<br>(780-1100 nm)   | 0.16<br>(850 nm)<br>0.1<br>(940 nm)                             | $6.6 \times 10^{10}$ <sup>(b)</sup><br>(850 nm)<br>$4.2 \times 10^{10}$ <sup>(b)</sup><br>(940 nm) | —   | —                       |  | <sup>13</sup> |
| $\text{FA}_{0.7}\text{MA}_{0.3}\text{Pb}_{0.5}\text{Sn}_{0.5}\text{I}_3$<br>(500-950 nm)    | 0.52<br>(930 nm)  | $7.5 \times 10^{11}$ <sup>(b)</sup><br>(930 nm)  | —   | 94/97 ns                |  | <sup>14</sup> |
| MASnI <sub>3</sub> nanowire array<br>(200-1000 nm)  | 0.47  | $8.8 \times 10^{10}$ <sup>(a)</sup>  | —   | 1.5/0.4 s               |  | <sup>15</sup> |
| MAPbI <sub>3</sub><br>(400-1000 nm)   | 4 (800 nm)  | —  | —   | 39/1.9 $\mu\text{s}$    |  | <sup>16</sup> |
| MAPbI <sub>3</sub><br>(400-1064 nm)   | 0.15<br>(820 nm)  | —  | —   | 120/80 ms               |  | <sup>17</sup> |
| MAPbI <sub>3</sub> nanocrystal<br>(400-980 nm)  | 1.42<br>(808 nm)<br>$4.43 \times 10^{-5}$<br>(980 nm)           | $1.7 \times 10^{13}$ <sup>(a)</sup><br>(808 nm)<br>$1.34 \times 10^8$ <sup>(a)</sup><br>(980 nm)   | —   | 0.28/0.34 s             |  | <sup>18</sup> |
| MAPbI <sub>3-x</sub> Cl <sub>x</sub><br>(350-1100 nm)                                       | $7.6 \times 10^8$<br>(895 nm)<br>$1.91 \times 10^9$<br>(598 nm) | $5.6 \times 10^{13}$ <sup>(b)</sup><br>(895 nm)  | —   | —                       |  | <sup>19</sup> |
| MAPbI <sub>3</sub><br>(600-900 nm)  | —   | $7.13 \times 10^{11}$ <sup>(b)</sup><br>(800 nm)   | —   | —                       |  | <sup>20</sup> |
| CsSnI <sub>3</sub><br>(350-1000 nm)   | 0.257<br>(850 nm)   | $1.5 \times 10^{11}$ <sup>(a)</sup><br>(850 nm)  | —   | 0.35/1.6 ms             |  | <sup>21</sup> |
| $\text{FA}_{0.85}\text{Cs}_{0.15}\text{Sn}_{0.5}\text{Pb}_{0.5}\text{I}_3$<br>(600-1000 nm) | 0.53<br>(940 nm)  | $6 \times 10^{12}$ <sup>(b)</sup><br>(940 nm)  | 103 | 58.3/860 ns             |  | <sup>22</sup> |
| $(\text{FASnI}_3)_{0.6}(\text{MAPbI}_3)_{0.4}$<br>(300-1000 nm)                             | 0.4<br>(950 nm)   | $1.1 \times 10^{12}$ <sup>(b)</sup><br>(900 nm)  | 167 | 6.9/9.1 $\mu\text{s}$   |  | <sup>23</sup> |

|  |  |  |      |               |           |
|--|--|--|------|---------------|-----------|
| MA <sub>0.5</sub> FA <sub>0.5</sub> Pb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>3</sub><br>(350-1000 nm)  | > 0.2<br>(800-950 nm)  | > 10 <sup>12</sup> (b)<br>(800-970 nm)   | —    | —             | 24        |
| MA <sub>0.975</sub> Rb <sub>0.025</sub> Sn <sub>0.65</sub> Pb <sub>0.35</sub><br>I <sub>3</sub><br>(300-1100 nm)   | 0.4<br>(910 nm)  | > 10 <sup>12</sup> (b)<br>(340-1000<br>nm)   | 110  | 0.04/0.468 μs | 25        |
| MASn <sub>x</sub> Pb <sub>1-x</sub> I <sub>3</sub><br>(300-1100 nm)  | 0.2<br>(940 nm)  | > 10 <sup>11</sup> (b)<br>(360-985 nm)   | 100  | 0.09/2.27 μs  | 26        |
| (FASnI <sub>3</sub> ) <sub>0.6</sub> (MAPbI <sub>3</sub> ) <sub>0.4</sub><br>(300-1000 nm)   | —  | ≈ 10 <sup>11</sup> (a)<br>(850 nm)   | —    | 19/13 ms      | 27        |
| CsPb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>3</sub> (5%<br>(PEA) <sub>2</sub> Pb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>4</sub> )<br>(700-900 nm)                                      | 0.27(850 nm)   | 5.42 × 10 <sup>14</sup> (b)<br>(850 nm)  | —    | —             | 28        |
| MA <sub>0.5</sub> FA <sub>0.5</sub> Pb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>3</sub><br>(2.5% (PEA) <sub>2</sub> Pb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>4</sub> )<br>(700-1000 nm) | ≈ 0.1<br>(800 nm)  | 1.6 × 10 <sup>12</sup> (b)<br>(800 nm)   | —    | 10/10 μs      | 29        |
| FA <sub>0.5</sub> MA <sub>0.45</sub> Cs <sub>0.05</sub> Pb <sub>0.5</sub> Sn <sub>0.5</sub> I <sub>3</sub><br>(300-1050 nm)  | 0.35<br>(950 nm)   | 2.21 × 10 <sup>11</sup> (b)<br>(758 nm)  | 185  | —             | 30        |
| (FASnI <sub>3</sub> ) <sub>0.6</sub> (MAPbI <sub>3</sub> ) <sub>0.4</sub><br>(500-1100 nm)   | 0.04<br>(900 nm)<br>0.01<br>(1100 nm)  | 2.24 × 10 <sup>10</sup> (a)<br>(900 nm)  | —    | 20/40 ms      | 31        |
| CsSn <sub>0.6</sub> Pb <sub>0.4</sub> I <sub>2.6</sub> Br <sub>0.4</sub><br>(454-860 nm)   | 21<br>(860 nm)   | 3.9 × 10 <sup>10</sup> (a)<br>(860 nm)   | —    | 0.74/0.56 s   | 32        |
| FA <sub>0.5</sub> MA <sub>0.5</sub> Sn <sub>0.5</sub> Pb <sub>0.5</sub> I <sub>3</sub><br>(367-1200 nm)  | 4.4 × 10 <sup>13</sup> (a)<br>1.2 × 10 <sup>3</sup><br>(395 nm)<br>1.1 × 10 <sup>3</sup><br>(455 nm)<br>24.73<br>(1200 nm) | 2.02 × 10 <sup>13</sup> (b)<br>(395 nm)<br>3.98 × 10 <sup>13</sup> (a)<br>1.52 × 10 <sup>12</sup> (b)<br>(455 nm)<br>1.01 × 10 <sup>12</sup> (a)<br>4.16 × 10 <sup>11</sup> (b)<br>(1200 nm) | 66.5 | 2.4/5.4 ms    | This work |

(a) Calculate via  $D^* = R \sqrt{\frac{A_{rea}}{2eI_{dark}}}$ , (b) Calculate via  $D^* = \frac{\sqrt{A_{rea}\Delta f}}{NEP}$

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